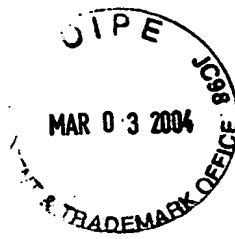


Docket Number: 040258-0307509

Client Reference: EL00022CDC-D1



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

KIYOSHI KOMIYAMA, et al.

Group Art Unit: 2812

Application No.: 10/760,581

Examiner:

Filed: January 21, 2004

Confirmation No.:

For: DEVICE AND METHOD FOR MONITORING PROCESS EXHAUST GAS,
SEMICONDUCTOR MANUFACTURING DEVICE, AND SYSTEM AND METHOD FOR
CONTROLLING SEMICONDUCTOR MANUFACTURING DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Since this Application was filed after July 2003 no copy of the U.S. patent is being supplied. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

Kenneth M. Fagin
Registration Number 37615

Date: March 3, 2004
PILLSBURY WINTHROP LLP
Telephone: (703) 905-2000
Facsimile: (703) 905-2500
P.O. Box 10500
McLean, VA 22102



PTO/SB/08a (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	1	of	1
-------	---	----	---

Complete if Known

Application Number	10/760,581
Filing Date	01/21/2004
First Named Inventor	KIYOSHI KOMIYAMA
Art Unit	2812
Examiner Name	
Attorney Docket Number	040258-0307509